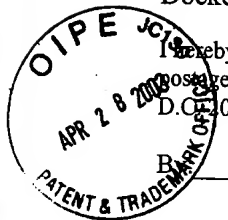


Docket No.: WRA-32830

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the date indicated below.

Wm Stemmer

Date: April 22, 2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
Before the Board of Patent Appeals and Interferences

Inventor : Karl Draganitsch et al.
Applic. No. : 09/817,573
Filed : March 26, 2001
Title : Method of Producing a Wafer Product, Assembly for Implementing
the Method, and Wafer Product Produced According to the Method
Examiner : Thuy Tran Lien Art Unit: 1761

NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO THE
BOARD OF PATENT APPEALS AND INTERFERENCES

Hon. Commissioner of Patents and Trademarks,
Washington, D. C. 20231

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the decision dated January 23, 2003 of the Primary Examiner finally rejecting claims 1-6.

The \$320.00 appeal fee is enclosed.

The Patent and Trademark Office is hereby given authority to charge Deposit Account No. 12-1099 of Lerner and Greenberg, P.A. for any fees due or deficiencies of payments made for any purpose during the pendency of the above-identified application.

Respectfully submitted,

Wm Stemmer

For Applicants

WERNER H. STEMER
REG. NO. 34,956

Date: April 22, 2003

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